

00862.022227.1

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Previous Examiner: D. Ben Esplin
Hiroshi KUROSAWA)	
	:	Previous Group Art Unit: 2851
Application No.: Divisional of Application No.)	
09/858,964, filed May 17, 2001	:	
)	
Filed: October 2, 2003	:	
)	
For: EXPOSURE APPARATUS, MAINTENANCE	:	October 2, 2003
METHOD THEREFOR, SEMICONDUCTOR)	
DEVICE MANUFACTURING METHOD, AND:		
SEMICONDUCTOR MANUFACTURING)	
FACTORY	:	

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Prior to examination on the merits, please amend the above-identified application as follows: